

2812

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Blalock et al.

Serial No.: 10/229,868

Filed: August 27, 2002

For: DEADHESION METHOD AND
MECHANISM FOR WAFER PROCESSING

Confirmation No.: 2027

Examiner: Unknown

Group Art Unit: 2812

Attorney Docket No.: 2269-3549.2US

CERTIFICATE OF MAILING

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PRELIMINARY AMENDMENT

Box Non-Fee Amendment
Commissioner for Patents
Washington, D.C. 20231

Sir:

Prior to examination of the above-referenced patent application on the merits, entry of the amendments as set forth herein is respectfully solicited.